

Electronic Acknowledgement Receipt

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Application Number:	10802150
International Application Number:	
Confirmation Number:	3946
Title of Invention:	Etching process including plasma pretreatment for generating fluorine-free carbon-containing polymer on a photoresist pattern
First Named Inventor/Applicant Name:	Keun-Hee Bai
Customer Number:	22150
Filer:	Frank Chau/Jaewoo Park
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Attorney Docket Number:	8021-215 (SS-19582-US)
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Amendment After Final	8021-215-response_200708 22110057.pdf	331621 <small>5a1b1908b64c69bb1bb0eada891e3566 05e4929</small>	no	11

Warnings:

Information:		
<table border="1"><tr><td>Total Files Size (in bytes):</td><td>331621</td></tr></table>	Total Files Size (in bytes):	331621
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